

Message Text

CONFIDENTIAL

PAGE 01 PARIS 21173 051554Z
ACTION EB-08

INFO OCT-01 EUR-12 ISO-00 DODE-00 NSAE-00 ICA-11
TRSE-00 SOE-02 DOE-15 CIAE-00 COME-00 ACDA-12
OES-07 /068 W
-----022043 060225Z /21

R 051542Z JUL 78
FM AMEMBASSY PARIS
TO SECSTATE WASHDC 4294

C O N F I D E N T I A L PARIS 21173

USOECD

EXCON

E.O. 11652: XGDS1
SUBJ: U.S. CENTRIFUGAL WAFER PROCESSING SYSTEM TO BUL-
GARIA

REF: COCOM DOC. (78) 428

1. AT JULY 4 MEETING ALL DELS EXCEPT GERMAN APPROVED
CASE. GERMAN DEL ASKED THE FOLLOWING RESERVE QUESTION:
"IN PARA 3 OF THE REQUEST, IT IS STATED THAT 'ONLY DIS-
CRETE STANDARD SEMI-CONDUCTOR DEVICES ARE USED IN THE
LOGIC AND TIMING CIRCUITS', WHILE IN THE BROCHURE UNDER
'FEATURES' IT IS SAID THAT THE LOGIC IS MADE IN CMOS AND
TTL COMPONENTSS." THE GERMAN AUTHORITIES WOULD LIKE TO
KNOW WHETHER A CMOS COMPONENT IS TO BE CONSIDERED A 'DIS-
CRETE STANDARD SEMI-CONDUCTOR DEVICE.' "

2. ACTION REQUESTED: RESPONSE TO GERMAN QUESTION.
SALZMAN

CONFIDENTIAL

NNN

Message Attributes

Automatic Decaptioning: X
Capture Date: 01 jan 1994
Channel Indicators: n/a
Current Classification: UNCLASSIFIED
Concepts: STRATEGIC TRADE CONTROLS, EXPORT LICENSES
Control Number: n/a
Copy: SINGLE
Draft Date: 05 jul 1978
Decaption Date: 01 jan 1960
Decaption Note:
Disposition Action: RELEASED
Disposition Approved on Date:
Disposition Case Number: n/a
Disposition Comment: 25 YEAR REVIEW
Disposition Date: 20 Mar 2014
Disposition Event:
Disposition History: n/a
Disposition Reason:
Disposition Remarks:
Document Number: 1978PARIS21173
Document Source: CORE
Document Unique ID: 00
Drafter: n/a
Enclosure: n/a
Executive Order: X1
Errors: N/A
Expiration:
Film Number: D780276-0829
Format: TEL
From: PARIS USOECD
Handling Restrictions: n/a
Image Path:
ISecure: 1
Legacy Key: link1978/newtext/t19780795/aaaadbud.tel
Line Count: 45
Litigation Code IDs:
Litigation Codes:
Litigation History:
Locator: TEXT ON-LINE, ON MICROFILM
Message ID: a007fc7a-c288-dd11-92da-001cc4696bcc
Office: ACTION EB
Original Classification: CONFIDENTIAL
Original Handling Restrictions: n/a
Original Previous Classification: n/a
Original Previous Handling Restrictions: n/a
Page Count: 1
Previous Channel Indicators: n/a
Previous Classification: CONFIDENTIAL
Previous Handling Restrictions: n/a
Reference: n/a
Retention: 0
Review Action: RELEASED, APPROVED
Review Content Flags:
Review Date: 18 may 2005
Review Event:
Review Exemptions: n/a
Review Media Identifier:
Review Release Date: n/a
Review Release Event: n/a
Review Transfer Date:
Review Withdrawn Fields: n/a
SAS ID: 2114918
Secure: OPEN
Status: NATIVE
Subject: U.S. CENTRIFUGAL WAFER PROCESSING SYSTEM TO BUL- GARIA
TAGS: ESTC, US, BU, COCOM
To: STATE
Type: TE
vdkgvwkey: odb://SAS/SAS.dbo.SAS_Docs/a007fc7a-c288-dd11-92da-001cc4696bcc
Review Markings:
Sheryl P. Walter
Declassified/Released
US Department of State
EO Systematic Review
20 Mar 2014
Markings: Sheryl P. Walter Declassified/Released US Department of State EO Systematic Review 20 Mar 2014